



CEA Saclay, Irfu/SPP, France

OUTLINE:

"Octopuce" Uniformity Studies in the Laboratory

DESY Test-Beam Track Reconstruction with Octopuce

Tests of IZM-3 InGrids

 Future InGrid Tests using Low Energy Electrons from PHIL at LAL

> LCTPC WP meeting #164 December 6, 2012

Integrated Electronics: Pixel Readout of Micro-Pattern Gas Detectors 3D Gaseous Pixel Detector → 2D (CMOS pixel chip readout) x 1D (drift time)

Bump bond pads for Si-pixel Detectors - Timepix or Medipix2 (256 × 256 pixels of size 55 × 55 µm2) serve as charge collection pads.

Each pixel can be set to: TOT ≈ integrated charge

SiO2

SiRN

TIME = Time between hit and shutter end

6kU

X600

20 Mm

19 21 SEI

Through POST-PROCESSING INTEGRATE MICROMEGAS directly on top of CMOS chip 1. Formation of protection layer (e.g. Si3N4) 2. Deposition of spacer material (e.g. SU8) 3. Deposition of the Grid material 4. Formation of structure "support" / grid "InGrid" Concept: 50 80 **Protection Layer (few μm)**

8kU

X300

50 Mm

11 22 SEI

"InGrid' Technology and "Driving" Developments

2005: Single "InGrid" Production

2011: Major Step Forward → InGrid Production on a wafer level (107 chips)



2009: "InGrid" Production on a 3 x 3 Timepix Matrix







The "Octopuce" (2009)



Non homogeneous area on the mesh of different chips



HV connections





"Grid irregularities"

Octopuce Studies & Fe55: Homogeneous Irradiation



Octopuce: Uniformity of the Response (I)

THRESHOLD = 1000 COUNTS

THRESHOLD = 2000 COUNTS



THRESHOLD = 4000 COUNTS



Non-sensitive (~ 1.5 mm) areas between chips

X (column number)

1500

Fe⁵⁵ Studies (26/07/2012):

He/Iso 80/20 Vmesh=390 V Vdrift =3000 V

500

Octopuce: Uniformity of the Response (II)

THRESHOLD = 6000 COUNTS

THRESHOLD = 8000 COUNTS





THRESHOLD = 10000 COUNTS



Non-sensitive (~ 1.5 mm) areas between chips:

More studies required to understand:

➢ if "dead" areas between chips decrease with increased drift field;

"dead" area on the outer edge as a function of the guard voltage

Octopuce: Cluster Size Distribution

Single electron sensitivity is very high for all (but 1 and 4) chips



Expected number of primary electrons in He/Iso (80/20) ~ 165

Octopuce: Total Cluster Charge

Chips 1 and 4 have a lower response (same trend as for the cluster size distribution) \rightarrow

Difference in amplification gap

Difference in threshold (too big to explain differences between 1 &4 and others)



Some differences in amplification gaps between different chips are seen by microscope (studies are not conclusive, might come from different thickness of the glue under the chips)



"The Octopuce" in the Large Prototype TPC

- Chips on a mezzanine board making wire bonding easier
- Large Prototype compatible
- Heat dissipator





Timepix pane for Large Prototype TPC

Octopuce in the Large Prototype TPC at 0 T





MAFalda: Medipix Analysis Framework

ROOT based analysis package developed by John Idarraga (LAL)

- C++ classes including processors:
 - OctoCEA (define in a few minutes)
 - Pattern recognition of tracks for low threshold



Use MAFalda as the first step \rightarrow implement reconstruction algorithm in Marlin TPC

MAFalda: Cluster Finding and Track Segments (I)

- Form cluster from the pixels with "discontinuity" < 40 pixels (each cluster should contain > 12 pixels)
- > Calculate the linear regression with all points in the cluster (red dotted line)
- Calculate residuals from the red line to each point (if > 80 % the points are within 20 pixels this is the "track segment" !



MAFalda: Cluster Finding and Track Segments (II)



Track Reconstruction

Reconstruct track from track segments (if more than 2 segments):

- > Apply data quality cuts to make sure all segments correspond to a given track
- \succ Perform a linear regression for all pixels on a track \rightarrow reconstructed track (blue dotted line)



Track Reconstruction: Residuals

An unbiased estimate of the single point resolution: $\sigma = Sqrt(\sigma 1 * \sigma 2)$:

Perform fit to all pixels and calculate the distance between each pixel and the position of the point of closest approach along the fitted track: σ 1 = Gaussian fit, when all pixels are included in the track fit σ 2 = Gaussian fit, omitting pixel under consideration from the track fit



DESY Test-Beam: Track Residuals

Summary of residuals ($\sigma = sqrt(\sigma 1 * \sigma 2)$) for different Z-coordinates:

(corresponds to the different positions of electron beam passing through the Large Prototype TPC)



DESY Test-Beam: Track Residuals as a function of Z (Large Prototype TPC)



Very low statistics, behavior needs to be understood

DESY Test-Beam: Time vs Z-coordinate correlation (Large Prototype TPC)



Saclay Micro-TPC with Timepix

Two micro-TPC boxes have been built

• Drift distance in micro-TPC (~ 10 cm) is large enough to allow study of single electron response from Fe⁵⁵ source







Studies of new IZN-3 InGrids in the Saclay micro-TPC

2011: Major Step Forward → InGrid Production on a wafer level 2013: 3rd IZM production run to post-process Timepix chips on a wafer level

X (column number)

2565

1282

256

5129

3847

256

Y

Received 6 IZM-3 InGrids in Saclay (earlier studies with IZM-3 InGrids have been performed in Bonn, NIKHEF)

Four chips are mounted on PCB (one does not work)

One InGrid is tested → in general, good behavior

WE use it two weeks!! Ar/Iso – 95/5

Guard ring problem in micro-TPC

Some noise and/or discharges

Some local grid issues



Proposal of a Flexible Detector Setup using Low Energy Electrons from PHIL at LAL

PHIL provides electrons with momentum 5 MeV/c and 10⁹ particles per bunch

Goal: obtain samples of "monochromatic" electrons

- with energy between 1 and 5 MeV and energy spread of better than 10%
- with adjustable intensity down to 10⁴ electrons per bunch

Study dE/dx by cluster counting using InGrid detectors the electron range 1-5 MeV

(earlier simulation results by M. Hauschild & NIKHEF experimental studies)

Joint proposal LAL & IRFU LAL contribution from S. Barsuk, L. Burmistrov, H. Monard, A. Variola

Spectrometer to sample "monochromatic" low energy electrons

Setup idea:

- Use electrons from PHIL
- Reduce energy/intensity using Al plug
- Select unique direction for electrons passing the plug with collimator 1
- Select required energy by half-turn of electron in the magnetic field (position of collimator 2)
- Adjust intensity/energy spread using collimator 2, positioned in front of tested detector



Momentum and angular spectra of electrons passing through the Al plug, depending on the plug thickness : Geant4 simulation



Example of sampling 1 MeV electrons from 5 MeV beam: from simulated 10⁸ electrons a sample of ~10³ electrons and momentum spread of ~10 % are obtained with collimator opening of 6 mm.

